

PATENT: 06491 USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLI-

CATION OF

Peng Zhang, et al.

SERIAL NO.

10/764,227

: GRP. ART UNIT:

1714

FILED

23 January 2004

: EXAMINER:

FOR

Immersion Lithography Fluids

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Respectfully submitted,

Rosaleen P. Morris-Oskanian Attorney for Applicant(s) Registration No. 47,321

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PTO/SB/08A (08-03)

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	INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			First Named Inventor	Peng Zhang, et al.	
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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		W. CONLEY, et al., "New Fluids for 193nm Immersion Lithography," Immersion Workshop held in conjunction with the Litho Forum of January 28, 2004 by International SEMATECH.	~
		S. ROBERTSON, et al., "Effects of Immersion Lithography on Diffusivity During PEB," Immersion Workshop held in conjunction with the Litho Forum of January 28, 2004 by International SEMATECH.	~
		B. SMITH, et al., "Water-Based 193nm Immersion Lithography," Immersion Workshop held in conjunction with the Litho Forum of January 28, 2004 by International SEMATECH.	<u> </u>

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